## **ELECTRONIC INFORMATION DISCLOSURE STATEMENT**

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

DIAPHRAGM VALVE WITH RELIABILITY ENHANCEMENTS
FOR ATOMIC LAYER DEPOSITION

Application Number: 10/609339

Confirmation Number: 9277

First Named Applicant: Jarmo Maula
Attorney Docket Number: 11429/13:3

Art Unit: Examiner:

Search string: (5520001 or 6752387 or 20030121608 ).pn

## **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5520001	1996-05-28	Miyamoto et al.		62	50.2
	2	6752387	2004-06-22	Nishizato et al.	B1	261	62

## **US Published Applications**

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030121608	2003-07-03	Chen et al.	<b>A</b> 1	156	345.33

## **Signature**

Examiner Name	Date